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EDITED BY
Wei Gong,
Zhejiang University, China

REVIEWED BY
Leiting Pan,
Nankai University, China
Jiaye He,
National Innovation Center for
Advanced Medical Devices, China

*CORRESPONDENCE
Yiyan Fei,
fyy@fudan.edu.cn
Lan Mi,
lanmi@fudan.edu.cn
Jiong Ma,
jiongma@fudan.edu.cn

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Design of an ellipsoidal mirror assisted oblique plane microscopy

Yuzhe Liu¹, Qiushu Chen¹, Yiyan Fei^{1*}, Lan Mi^{1*} and
Jiong Ma^{1,2,3*}

¹Department of Optical Science and Engineering, Shanghai Engineering Research Center of Ultra-Precision Optical Manufacturing, Key Laboratory of Micro and Nano Photonic Structures (Ministry of Education), Fudan University, Shanghai, China, ²Institute of Biomedical Engineering and Technology, Academy for Engineer and Technology, Fudan University, Shanghai, China, ³Shanghai Engineering Research Center of Industrial Microorganisms, The Multiscale Research Institute of Complex Systems (MRICS), School of Life Sciences, Fudan University, Shanghai, China

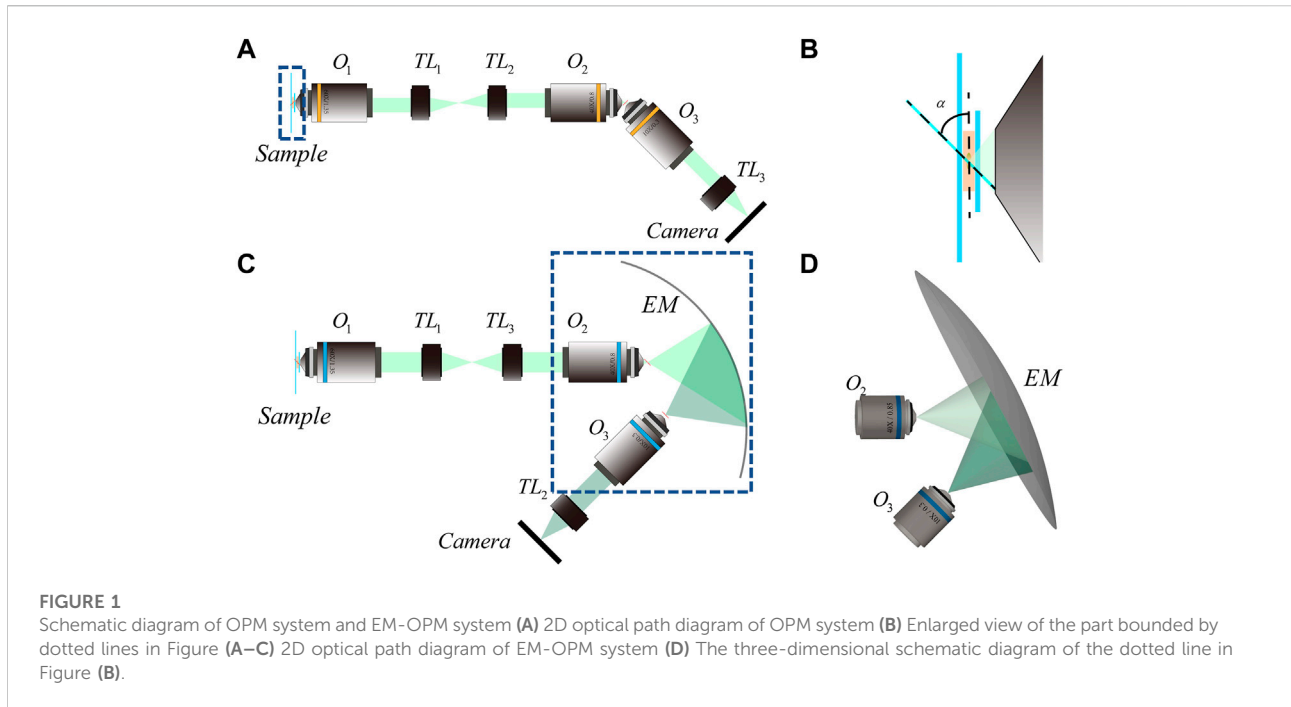
Using one objective for excitation and detection simultaneously, oblique plane microscopy (OPM) provides a mounting-friendly approach for optical sectioning. Unfortunately, the original OPM has three major defects: the mechanical constraints when placing the objectives, the phase loss and the resulting anisotropy of the point spread function (PSF). In order to alleviate the above defects, an ellipsoidal mirror assisted oblique plane microscopy (EM-OPM) was proposed. By inserting an ellipsoidal mirror into the optical path to help collect the light beam, the problem of placing the objectives was solved. The numerical calculation results showed that EM-OPM can obtain higher relative light intensity and larger effective area of exit pupil than OPM when the tilt angle of the light sheet becomes larger. The imaging simulation results showed that EM-OPM effectively solves the problem of resolution reduction in the Y direction of OPM. In addition, optimization of the higher-order terms of the ellipsoidal mirror further improved the imaging ability of EM-OPM in large field of view (FOV).

KEYWORDS

oblique plane microscopy, (point spread function), phase loss, mechanical constraint, ellipsoidal mirror, light-sheet fluorescence microscopy, anisotropy

1 Introduction

In order to achieve high-speed, high-resolution, low damage and large FOV imaging simultaneously, light sheet fluorescence microscopy (LSFM) came into being [1–3]. The biggest difference between light sheet microscopy and wide field microscopy comes from different illuminating methods. In classical configuration of LSFM, there are two orthogonally placed objective lenses with the sample at the common focal point. One objective lens, also known as the illumination objective, focus laser light to a thin sheet which is always perpendicular to the optical axis of the other objective also known as the detection objective. The key point of LSFM is that only the sample located in the focal plane of the detection objective lens is illuminated, while the upper and lower samples are



not affected. Therefore, LSFM can be used for long-term biological studies with high axial resolution and minimal phototoxicity.

Although LSFM has the above advantages, it has some limitations. The dual objective geometry and the need for side-on illumination restricts the type of sample that can be mounted between the objectives. In addition, in a high-resolution LSFM system, the sample has to directly contact the non-sterile optical surface to ensure the high numerical aperture of the immersion objective lens. These challenges have led to innovative strategies for optical path design, including LSFM that uses the same objective lens for illumination and detection [4, 5].

In 2008, Dunsby proposed oblique plane microscopy (OPM) to enable LSFM using a single objective to illuminate the specimen and collect the resulting fluorescence at the same time [6]. As shown in Figure 1A, the light sheet emitted from the edge of O_1 illuminate the sample obliquely. The fluorescence illuminated by the light sheet is also captured by O_1 but cannot be imaged by it directly because of the severe optical aberrations. The solution in OPM is to employ a one-to-one magnification system which simultaneously follow both the sine and Herschel condition by introducing O_2 [7]. The oblique intermediate real image is then brought to lie perpendicular to the optical axis of O_3 and can be imaged in a conventional way by a camera. Due to the improvement of illumination path, OPM can be assembled based on standard inverted microscopes, and is suitable for traditional sample placement and laser based auto focusing. However, there are three main defects in the original OPM: 1, mechanical constraint between O_2 and O_3 ; 2, Loss of phase information

on pupil plane (Short for Phase Loss); 3. Anisotropy of PSF [8, 9]. For the first defect, in addition to sacrificing the numerical aperture of O_3 for working distance, installing a micro mirror after O_2 can also eliminate the mechanical size limitation between O_2 and O_3 [10–12]. However, the fine fabrication and accurately installation of a micro mirror is technically challenging. Using a diffractive grating can achieve the same goal, but the intensity will be dispersed by the diffractive element [13]. To mitigate the impact of the second defect, Yang et al introduced a small special water container at the rear focus to change the refractive index of the light beam on both sides, so that almost all beams from O_2 can be collected by O_3 [14]. Although the phase loss of the system is effectively reduced, the addition of the water container increases the difficulty of focusing the system and intensifies the mechanical constraint between O_2 and O_3 . A similar idea was also put forward later [15], while facing the same challenge. For the third defect, Kim et al introduced a polarizer to change the polarization state of the beam thus improve the anisotropy of the overall PSF [16]. However, the improvement is unstable and the polarized beam splitter (PBS) in the optical path makes the phase loss more serious. To sum up, OPM and its existing improved system cannot solve the three defects mentioned above at the same time.

In this paper, inspired by the optical property of ellipse, we proposed an ellipsoidal mirror assisted oblique plane microscopy (EM-OPM), which provides some advantages over the original OPM and other OPMs. In this configuration, the light beam emitted by O_2 is collected by O_3 after being reflected by the ellipsoidal mirror, thus avoiding the top-to-top placement of O_2

and O_3 . Numerical results demonstrate the advantages of EM-OPM in terms of relative light intensity and relative effective pupil area. Imaging simulation results prove that the resolution of EM-OPM in Y direction is improved. In addition, the optimization of ellipsoidal mirror further improves the large FOV imaging capability of EM-OPM.

2 Materials and methods

2.1 EM-OPM

As mentioned above, the original OPM has three defects. In order to solve these three problems, we proposed a new optical configuration, namely EM-OPM, which is expected to solve these three defects simultaneously. Except for the introduction of an ellipsoidal mirror (EM) between O_2 and O_3 , EM-OPM uses elements similar to the original OPM. The expression of the EM is:

$$z = \frac{cr^2}{1 + \sqrt{1 - (1+k)c^2r^2}} \quad (1)$$

where c represents the curvature, k represents the conic coefficient. In our design, $c = 0.01$ and $k = 0.01$. r is the unit radial coordinate and z is the height of ellipsoidal mirror.

The way the sample is illuminated is depicted in Figure 1B. The inclined light sheet used for illuminating the sample in OPM is formed by scanning an inclined beam with an angle of α to the focal plane. The layout of EM-OPM is shown in Figure 1C. The back focus of O_2 is coincident with one of the focuses of EM when back focus of O_3 is coincident with the other. By adjusting the tilting angle of each element, the major axis of EM is parallel to the light sheet and perpendicular to the optical axis of O_3 at the same time. Although the real image of the sample is still inclined to the focal plane of O_1 , it lies parallel to the focal plane of O_3 , thus make the ordinary flat field imaging using O_3 possible. Our design can be understood as an extension of the remote focusing (RF) system [17], because the information of the sample is further copied from the back focal plane of O_2 to a more flexible space by an EM.

2.2 Mechanical constraint

The mechanical constraint of O_2 and O_3 is mainly due to the fact that the working distances of the two objective lenses is far less than their mechanical dimensions. To make sure that the objectives will not grind against each other, the working distance (WD_2 for O_2 and WD_3 for O_3) and the radius of the glass cover plate (r_{CG2} for O_2 and r_{CG3} for O_3) should meet at least one of the following requirements:

$$\begin{cases} WD_2 + WD_3 \cdot \tan \alpha > r_{CG2} \cdot \tan \alpha \\ WD_2 \cdot \cos \alpha + r_{CG2} \cdot \sin \alpha > r_{CG3} \end{cases} \quad (2)$$

In the system proposed by Dunsby, O_2 is a $40\times/0.85$ air objective with $r_{CG2} = 3.750$ mm and $WD_2 = 0.200$ mm. To meet the requirements above when $\alpha = 45^\circ$ for example, WD_3 must be greater than 2.510mm, otherwise r_{CG3} must be less than 2.793 mm. We can use d , the distance between the vertices of O_2 and O_3 , to indicate the severity of the mechanical constraint. In OPM:

$$d = \sqrt{WD_2^2 + WD_3^2 + 2 \cdot WD_2 \cdot WD_3 \cdot \sin \alpha} \quad (3)$$

In EM-OPM, d is determined by the parameters of the EM, which can be calculated as:

$$d = 2 \cdot \sqrt{\frac{k}{c^2(1-k)^2}} \quad (4)$$

2.3 Phase loss

The phase loss mainly occurs between O_2 and O_3 (Some OPM using a planar micro mirror lose extra 50% intensity due to the introduction of PBS). To make it clear, it is the reduction in NA and the tilting placement of O_3 that result in the phase loss. In order to calculate the phase loss, it is necessary to calculate the initial pupil ignoring O_3 and the effective pupil of the complete system. The calculation of the initial and effective pupil can be based on either the strict analytic geometry method [18] or the Monte Carlo algorithm. In this paper, the three-dimensional point clouds representing the pupils of OPM and EM-OPM are obtained after ray tracing using Monte Carlo algorithm. The Delaunay triangulation algorithm is used to convert the three-dimensional point cloud into a triangular mesh [19]. Then, all the meshes are traversed, and the area of each triangular mesh is calculated separately. After accumulation, the approximate effective pupil area can be obtained. Based on the theory above, we compared the effective pupil of OPM and EM-OPM.

2.4 Point spread function

The third defect of OPM is the anisotropy of PSF. Because objective lenses with large numerical aperture are used, the paraxial approximation scalar diffraction theory is no longer applicable [20]. Based on the vector diffraction theory [21], the electromagnetic field distribution at any point $p(x, y, z)$ in the focus area of the objective lens can be regarded as the superposition of all diffracted plane waves that can pass

through the pupil of the objective lens within the solid angle (determined by NA).

$$E(x, y, z) = -\frac{i}{\lambda} \int_0^\beta \int_0^{2\pi} \sin \theta \cos \theta A(\theta, \varphi) P(\theta, \varphi) \times \exp[ikn(z \cos \theta + x \sin \theta \cos \varphi + y \sin \theta \sin \varphi)] d\theta d\varphi \quad (5)$$

With $0 < \theta < \beta$, where β is the maximum focus angle of the objective lens. φ represents the azimuth angle in the object plane, λ represents the wavelength. $A(\theta, \varphi)$ is the amplitude of the incident beam. $P(\theta, \varphi)$ indicates the polarization state of the EM field in the focal region.

The effective pupil can be cut into a large number of sub regions by using the Monte Carlo algorithm to trace a large number of rays. The position of each sub region can be approximately determined by one of the points $u_i (\theta_i, \varphi_i, r_i)$. It is approximately considered that the plane wave from each sub region to the point p has a unique direction vector. Then Eq. (5) can be written by a discretely way as:

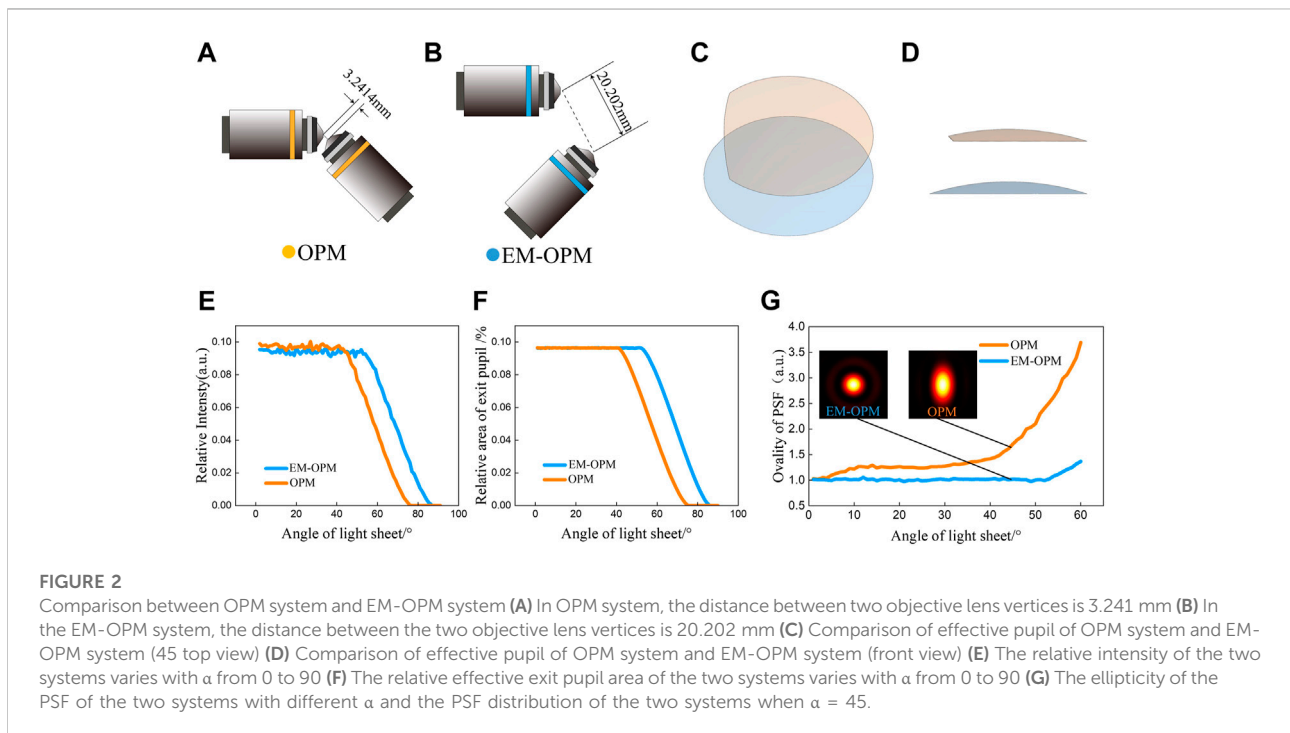
$$E(x, y, z) = \sum_{(u_i (\theta_i, \varphi_i, r_i) \in R)} \sin \theta_i \cos \theta A(\theta_i, \varphi_i) P(\theta_i, \varphi_i) \times \exp[ikn(z \cos \theta_i + x \sin \theta_i \cos \varphi_i + y \sin \theta_i \sin \varphi_i)] \quad (6)$$

In this study, the numerical calculation is programmed by a personal code script based on Matlab software. The code allows to simulate PSFs for OPM and EM-OPM under different conditions, such as different NA, different light sheet angles, etc.

3 Results and discussion

As a single-objective LSMF methods, OPM offers a convenient approach for optical sectioning using a conventional epi-fluorescence microscope. The trade-offs it has to make in order to achieve the convenience of sample mounting sacrifice the imaging quality. Unfortunately, all of the improved configurations up to now have failed to reduce the three defects mentioned above simultaneously. By inserting an ellipsoidal mirror into the space near the focal region of O_2 and titling the following elements accordingly, we reconstructed OPM into EM-OPM. EM-OPM has obvious progress compared with OPM, especially in the alleviation of the three defects. We used numerical calculations to illustrate these advances.

We proved the alleviation of the first defect by comparing the space between O_2 and O_3 in EM-OPM and OPM. Except for some extremely high NA objectives for special purposes, only a series of small NA objectives with $\times 10$ magnification can meet the requirements in Eq. (5). Therefore, O_3 is a $10\times/0.3$ air objective which has a working distance of 3.100 mm in original OPM. Even it is very easy to align and the working distance is plenty, the distance between the two vertices is only 3.241 mm (Figure 2A). In contrast, in EM-OPM, the distance between the two vertices is relaxed to 20.202 mm (Figure 2B). It significantly eased the mechanical constraint and therefore increased the flexibility of O_3 selection.



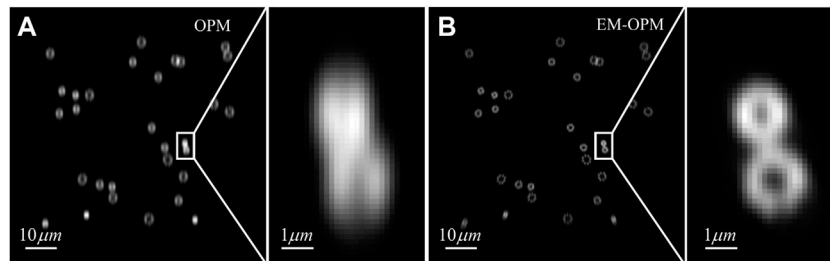


FIGURE 3
Simulated image obtained by imaging with OPM and EM-OPM (A) Simulation image of OPM (B) Simulation image of EM-OPM.

The effective pupil of OPM and EM-OPM when $\alpha = 45$ are shown in Figures 2C,D. Both remaining a small part of the spherical shell, the effective pupil of OPM is cut out while the effective pupil of the EM-OPM is still complete. Due to the reduction of NA of objective lens, the pupil of both systems becomes smaller. Effective pupil of EM-OPM faithfully reflects the reduction of NA but avoids the influence of the inclined placement of O_2 and O_3 . When $\alpha < 42$, the relative light intensity and the relative effective pupil area of OPM and EM-OPM are approximately the same (Figure 2E). However, EM-OPM system has higher relative light intensity and larger effective pupil area when $\alpha \geq 42$ (Figure 2F). When α is too large, both systems are unable to collect the light from O_2 . For OPM, α should be smaller than 75, while for EM-OPM, α should be smaller than 85. Calculation result shows that EM-OPM can make more effective use of fluorescence. This is exactly the goal of researchers to reduce phase loss when improving OPM.

The third defect of OPM system, namely the anisotropy of PSF, can also be understood as the loss of resolution in Y direction. Generally, the more complete the effective pupil, the more complete the high-frequency information contained in the optical system, which means that the resolution of the system in each direction is not lost. According to the results in the previous section, the PSF of EM-OPM is predicted to be more isotropic. The numerical calculation results also agree with this idea. In Figure 2G, the anisotropy of PSF is measured by a defined parameter, μ calculated as:

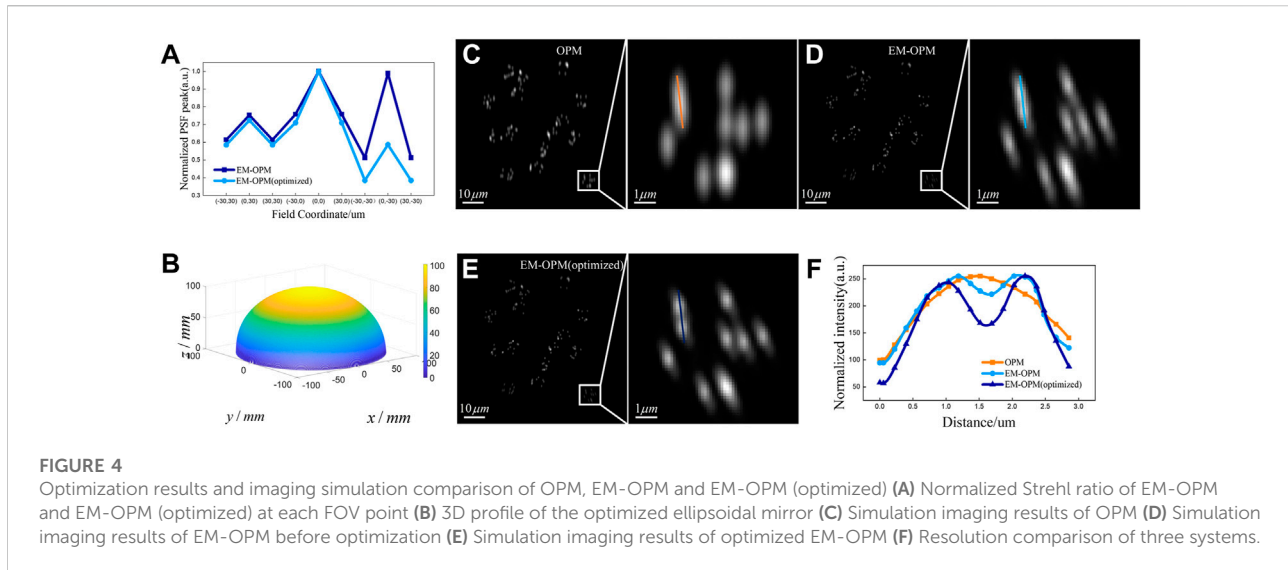
$$\mu = \frac{\text{FWHM}_y \text{ of PSF}}{\text{FWHM}_x \text{ of PSF}} \quad (7)$$

With the increase of α , μ of the OPM increases, while μ of EM-OPM is relatively stable. For example, when $\alpha = 45$, the PSF of EM-OPM presents a perfect quasi-Gaussian distribution, while the PSF of OPM is elongated along the y-direction. In other words, EM-OPM can recover the Y direction loss of resolution in OPM.

We then demonstrate the power of EM-OPM by presenting the imaging simulation of OPM and EM-OPM. We focus on the

imaging performance of Fluorescence conjugated to the focal plane of O_3 , therefore the simulation results are 2D images. Firstly, we generate the ground truth pattern used for simulation. Here to highlight the difference in resolution, we choose hollow circular structure to be the sample pattern which is aimed to model nuclear pore complexes (NPCs). This pattern consists of octagons labelled at their vertices for the convenience of calculation. The positions of the centers of octagons randomly distributed within an active area of $81.92 \times 81.92 \mu\text{m}^2$ and the octagon radius is randomly distributed between 400 nm and 1200 nm. Secondly, we simulate the imaging process. In most algorithms used for single molecule localization microscopy (SMLM) simulation [22, 23], PSF is usually space-invariant. In order to accurately study the imaging results under different FOV, we have established the communication between our imaging simulation algorithm and Zemax/OpticStudio™. Because the built-in ray tracing package of Zemax can easily calculate the PSF at different FOVs. Therefore, the PSF of different areas in the FOV can be obtained and then convolved with the ground truth image. Figure 3A is the simulation result obtained using the OPM system, and Figure 3B is the one obtained using the EM-OPM system. The improvement of EM-OPM can be found by comparing the imaging results of the entire FOV or ROI area delineated by white solid lines. OPM will significantly reduce the Y resolution of the image, while EM-OPM can achieve higher resolution in both directions.

EM-OPM has significant advantages over OPM, but the ellipsoidal mirror will introduce serious coma, which limits the use of EM-OPM in large FOV. It is also illustrated by the severe degradation of imaging quality in the large FOV area in Figure 3B (note the two octagons marked with arrows). In order to improve the imaging capability in large FOV, we designed an optimization function to comprehensively evaluate the imaging ability of each vertex in the field of $60 \times 60 \mu\text{m}^2$, and optimized the high-order terms in the expression of EM. The optimization results are shown in Figure 4A,B. It can be seen that the normalized Strehl ratio of the optimized EM-OPM at each



FOV point is higher than that of the pre-optimized EM-OPM. The optimization result indicates that the imaging contrast of the system at each position in the large FOV is improved.

The imaging simulations of OPM, EM-OPM and EM-OPM (optimized) were then carried out respectively. To compare the resolution and edge distortion of these three systems at the same time, fluorescence beads distributed randomly are chosen to be the ground truth pattern. Several fluorescent beads are set to be in a group, and the center of each group are still randomly distributed within an active area of $81.92 \times 81.92 \mu\text{m}^2$. We also define that the fluorescent beads of each group are randomly distributed in a circle with a radius of 3000 nm . The simulation results of the three systems are shown in Figures 4C–E respectively. The simulation results prove again that the original OPM system has the problem of reduced resolution in the Y direction, which makes it impossible to distinguish some fluorescent spheres with close distance using OPM. In EM-OPM, the problem of PSF anisotropy has been significantly alleviated. However, the decrease of image contrast and serious side lobe indicate that the imaging capability in large FOV is still unsatisfying. Fortunately, the optimized EM-OPM make some change. A line segment is used to extract the intensity distribution in the ROI regions in Figures 4C–E and the resolution comparison of the three systems is shown in Figure 4F. It can be seen that OPM is unable to distinguish the two fluorescent beads that are close to each other, EM-OPM can barely distinguish them, and the optimized EM-OPM further improves the resolution.

4 Conclusion

EM-OPM proposed in this paper is an improvement based on OPM. An ellipsoidal mirror is inserted into the space

between O_2 and O_3 . The optical property of the ellipse is used to collect the beam so that the mechanical constraint between O_2 and O_3 can be solved. The change of relative intensity and the change of relative effective pupil area under different tilt angles of the light sheet are studied and compared by numerical calculation method. The results prove that: the relative light intensity and the relative effective pupil area of OPM and EM-OPM are approximately the same when $\alpha < 42$, and the relative light intensity and the relative effective pupil area of EM-OPM are larger than that of OPM when $\alpha \geq 42$. This means EMOPM can make more effective use of fluorescence and retain as much optical high-frequency information as possible. The alleviation in phase loss is also the basis for the improvement of PSF anisotropy. Compared to OPM, EM-OPM has higher resolution in Y direction for any tilt angle of the light sheet.

Due to the complexity of the actual imaging system, image simulation based on space-variant PSFs is carried out. Simulation results show that OPM loses resolution in Y direction, while EM-OPM can achieve higher resolution in both directions. The simulation results of imaging also reveal the weakness of EM-OPM in the large FOV imaging. In order to improve the imaging ability in large FOV, we carried out optimization for high order terms of the ellipsoidal mirror. The optimization improved the normalized Strehl ratio of the system at each vertex within the field of $60 \times 60 \mu\text{m}^2$. The later imaging simulation proves that the optimized EM-OPM further improves the resolution and contrast in large FOV. With the development of ultra-precision machining capability of free-form surface, the optimized EM-OPM is expected to replace OPM in low and medium resolution applications.

Data availability statement

The raw data supporting the conclusions of this article will be made available by the authors, without undue reservation

Author contributions

YL and JM conceived the project; YL performed the experiments; YL wrote the manuscript and performed simulation and data analysis; QC, YF, LM, and JM revised the manuscript.

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Conflict of interest

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